

## Transaction Information

Tool ID	LKTK760
Tool Status	Running Wafers
Location	Woodlands, Singapore
Wafer Size	300 mm
Fab Section	Lithography
Tool Available Date	2024-01-01

## General Product Information

Vendor Supplier	TOKYO ELECTRON LIMITED
Model	LITHIUS
Vintage	2006
Serial No	G260816
Asset Description	TEL LITHIUS KRF DUV Track
Software Version	3.00.71
CIM	SECS
Process	KRF

## Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	Main Tool	1	OK
Main System	DEV	5	OK
Main System	TCU	1	OK
Main System	BWEE	1	OK
Handler System	PRA	2	OK
Handler System	CRA	1	OK
Handler System	IRAS	1	OK
Handler System	IRAM	1	OK
Factory Interface	FOUP	4	OK
Options System			
Others			

## Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
DEV Chemical Cabinet	1	OK
AC Power Box	1	OK
T&H Controller	1	OK
COT Chemical Cabinet	1	OK

## Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	

# Tool Pictures

General	LKTK760 Machine Configuration
---------	-------------------------------

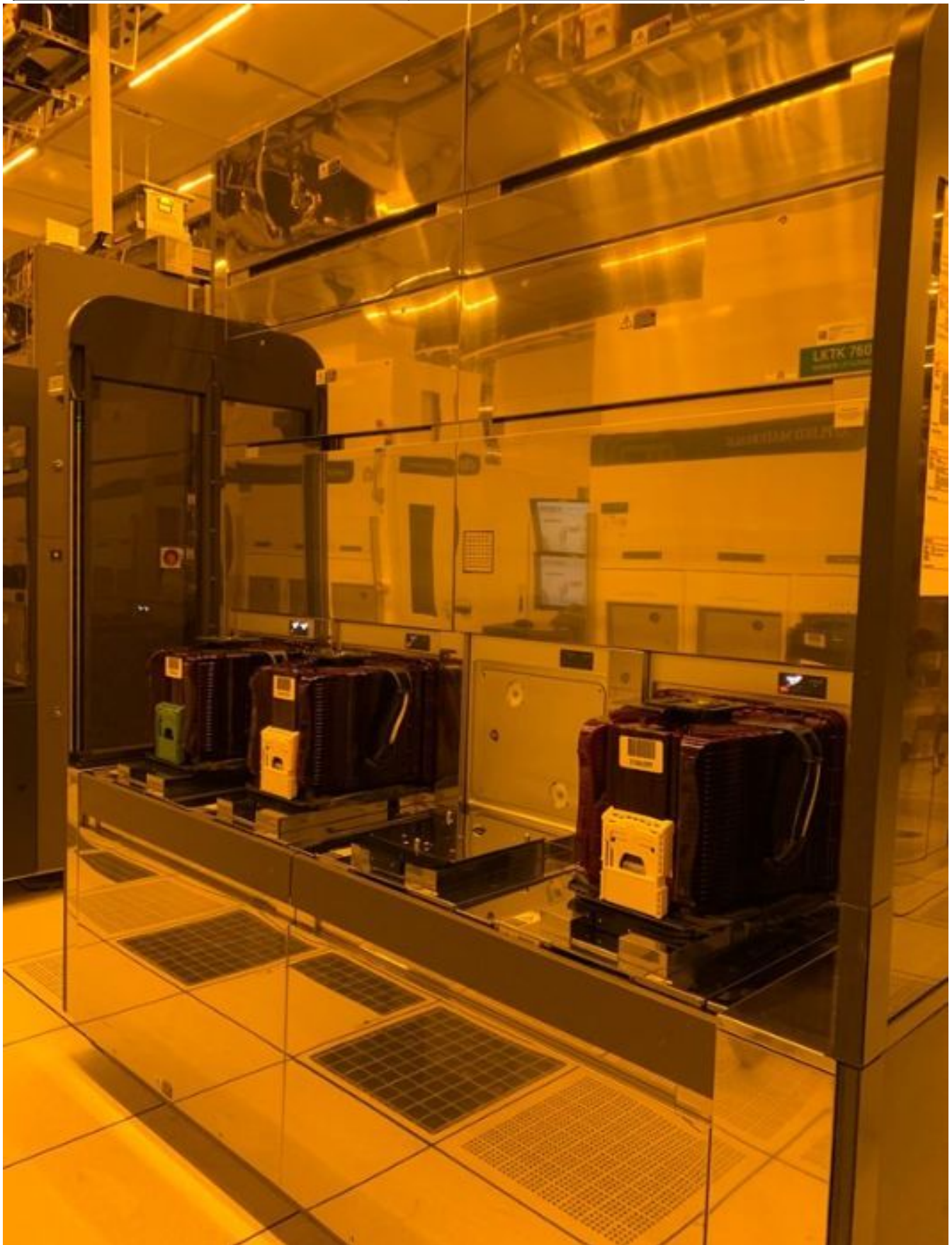
## G260816 LKTK-760

		2-23	2-58	2-49 CPHP	3-36	3-23	4-9 BWEE	
1-1 FOUN	1-0 CRA	2-18 CPHP	2-57	2-44 CPHP	3-35	3-18 CPHP	4-8	
		2-17 CPHP	2-56 ADH	2-43 CPHP	3-34	3-17 CPHP	4-7 SBU	
1-2 FOUN		2-16 CPHP	2-55 ADH	2-42 CPHP	3-33 LHP	3-16 CPHP	4-6 SBU	
		2-15 CPHP	2-54 ADH	2-41 CPHP	3-32 LHP	3-15 CPHP		
1-3 FOUN		2-14 CPHP	2-0 PRA	2-40 CPHP	3-0 PRA	3-14 CPHP	4-0 IRAM	
		2-13		2-39		3-13		
		2-12 HCP		2-38 HCP		3-12 CPHP		
		2-11		2-37		3-11		
		2-10 HCP		2-36 HCP		3-10 CPHP		
		2-9 TRS		2-35 TRS		3-9		
		2-8 WCPL		2-34 WCPL		3-8 HCP		
		2-7 TRS		2-33		3-7		
1-4 FOUN		2-6 HCP	2-32 HCP	3-6 HCP			5-0 IRAS	
			2-5 TCT	3-5 DEV		4-5 THS		
			2-4 TCT	3-4 DEV		4-4		
			2-3 COT	3-3 DEV		4-3 TRS		
		2-2 COT	3-2 DEV		4-2 IHCP			
		2-1 COT	3-1 DEV		4-1 IHCP			

※本図はCONFIGの情報のみ示しています。

※ This figure shows only module configuration.

















Manufacture Serial

LKTK760 Serial Number



## Additional Configuration Files

# Additional Configuration Files

	<b>Machine ID</b>	<b>G260816</b>
	<b>Software</b>	<b>3.00.71</b>
	<b>Tool Model</b>	<b>TEL LITHIUS</b>
	<b>Block</b>	<b>2 Blocks</b>
<b>CSB</b>	<b>Loadport</b>	<b>4</b>
<b>PRB1</b>	<b>TCT</b>	<b>2</b>
	<b>COT</b>	<b>3</b>
	<b>HCP</b>	<b>6</b>
	<b>WCPL</b>	<b>2</b>
	<b>ADH</b>	<b>3</b>
	<b>CPHP</b>	<b>11</b>
<b>PRB2</b>	<b>DEV</b>	<b>5</b>
	<b>HCP</b>	<b>2</b>
	<b>CPHP</b>	<b>7</b>
	<b>LHP</b>	<b>4</b>
<b>IFB</b>	<b>BWEE</b>	<b>1</b>
	<b>IHCP</b>	<b>2</b>
<b>Others</b>	<b>Pump Type</b>	<b>Entegris RGEN-02 4cc Entegris RGEN-02 10cc</b>
	<b>Dev Nozzle Type</b>	<b>NLD Nozzle</b>
<b>Accessories</b>	<b>AC Power Box</b>	<b>1</b>
	<b>T&amp;H Controller</b>	<b>Asahi</b>
	<b>Chemical Cabinet</b>	<b>2</b>